

#5

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Eran Dvir, Moshe Finarov, Eli Haimovich, Benjamin Shulman
Assignee: Nova Measuring Instruments, Ltd.
Title: Apparatus For Optical Inspection Of Wafers During Polishing
Serial No.: 09/498,926 Filing Date: February 4, 2000
Examiner: E. Morgan Group Art Unit: 3723
Docket No.: M-3417-2C US

San Jose, California
November 15, 2000

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

ASSOCIATE POWER OF ATTORNEY (37 C.F.R. § 1.34)

Dear Sir:

The undersigned Attorney of Record hereby appoints the attorney named below as an Associate Attorney in the above-identified application with full powers to prosecute said application; to make alterations and amendments therein; to receive all notices, communications and said Letters Patent at the address indicated below; and to transact all business in the U.S. Patent and Trademark Office in connection therewith.

The undersigned Attorney of Record hereby appoints:

Jerome R. Smith, Jr., Reg. No. 35,684

FAX RECEIVED

Please address all further correspondence in the above case to:

NOV 15 2000

David W. Heid
Skjerven, Morrill, MacPherson LLP
25 Metro Drive, Suite 700
San Jose, California 95110
Telephone (408) 453-9200
Facsimile (408) 453-7979


GROUP 3700

Certification of Facsimile Transmission

I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

 11/15/00
Signature Date

Respectfully submitted,


David W. Heid
Attorney for Applicants
Reg. No. 25,875

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP
25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979

Attorney Docket No. M-3417 US

ASSIGNMENT

For good and valuable consideration, receipt of which is hereby acknowledged, we

Eran Dvir of 15 Hapalmach St., Givatayim 53406, Israel
Moshe Finarov of 4/25 Shkolnik St., Rehovot 76209, Israel
Eli Haimovich of 23 Haarava St., Moshav Magshimim 56910, Israel
Benjamin Shulman of 524/20 Hagana St., Rehovot 76100, Israel

hereby sell, assign and transfer to Nova Measuring Instruments, Ltd., an Israeli corporation, having a place of business at Weizmann Scientific Park, P.O.Box 266, Rehovot 76100, Israel, its successors and assigns, the entire right, title and interest throughout the world in our invention in

APPARATUS FOR OPTICAL INSPECTION OF WAFERS DURING POLISHING

the specification of which was filed on June 29, 1995 and assigned Serial No. 08/497,382, and all patent applications and patents of every country for said invention, including divisions, reissues, continuations and extensions thereof, and all rights of priority resulting from the filing of said applications; we authorize the above-named assignee to apply for patents of foreign countries for said invention, and to claim all rights of priority without further authorization from us; we agree to execute all papers useful in connection with said United States and foreign applications, and generally to do everything possible to aid said assignee, their successors, assigns and nominees, at their request and expense, in obtaining and enforcing patents for said invention in all countries; and we request the Commissioner of Patents and Trademarks to issue all patents granted for said invention to the above-named assignee, its successors and assigns.

Executed this 1 day of 10, 1995.

Eran Dvir
(Full Name)


(Inventor's Signature)

Witness:

Giora Dishon G. Dishon

Witness:

Judith Gothilf J. Gothilf

Executed this 1 day of 10, 1995.

Moshe Finarov
(Full Name)


(Inventor's Signature)

Witness:

Giora Dishon G. Dishon

Witness:

Judith Gothilf J. Gothilf

Attorney Docket No. M-3417 US

Executed this 1 day of 10, 1995.Eli Haimovich
(Full Name)Eh Haimovich
(Inventor's Signature)

Witness:

Giora Dishon - G. Dish

Witness:

Judith Gethilf - J. GethilfExecuted this 1 day of 10, 1995.Benjamin Shulman
(Full Name)Ally L.
(Inventor's Signature)

Witness:

Giora Dishon - G. Dish

Witness:

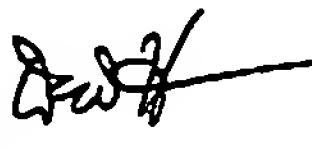
Judith Gethilf - J. Gethilf

SKJERVEN
MORRILL
MACPHERSON LLP**FACSIMILE COVER SHEET**

Date: November 15, 2000
To: Examiner Eileen P. Morgan
U.S. Patent and Trademark Office

Fax Telephone #: 703-305-3579

Office Telephone #: 703-308-1743

From: David W. Heid 
Subject: Attached Power of Attorney
Client/File: M-3617-2C US

Date Sent:	
Time Sent:	
Fax Operator:	

This transmittal consists of 2 page(s), including this cover sheet.

Message:**Please deliver to Examiner Eileen P. Morgan**

Applicants: Eran Dvir, Moshe Finarov, Eli Haimovich, Benjamin Shulman
Assignee: Nova Measuring Instruments, Ltd.
Title: Apparatus For Optical Inspection Of Wafers During Polishing
Serial No.: 09/498,926
Filed: February 4, 2000
Atty Docket No.: M-3417-2C US

FAX RECEIVED

NOV 15 2000

GROUP 3700**ENCLOSED:**

1. Associate Power of Attorney (1 page)

694549 v1

If you do not receive all pages, please call (408) 453-9200

THE INFORMATION CONTAINED IN THIS FACSIMILE MESSAGE IS INTENDED ONLY FOR THE PERSONAL AND CONFIDENTIAL USE OF THE DESIGNATED RECIPIENT(S) NAMED ABOVE. THIS MESSAGE MAY BE AN ATTORNEY-CLIENT COMMUNICATION, AND AS SUCH IS PRIVILEGED AND CONFIDENTIAL. IF THE READER OF THIS MESSAGE IS NOT THE INTENDED RECIPIENT OR AN AGENT RESPONSIBLE FOR DELIVERING IT TO THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT YOU HAVE RECEIVED THIS DOCUMENT IN ERROR AND THAT ANY REVIEW, DISSEMINATION, DISTRIBUTION OR COPYING OF THIS MESSAGE IS STRICTLY PROHIBITED. IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR, PLEASE NOTIFY US IMMEDIATELY BY TELEPHONE AND RETURN THE ORIGINAL MESSAGE TO US BY MAIL. THANK YOU.